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Abstract:

The invention provides a process for producing a substrate (1) having a conductor arrangement (4, 41, 42) which is suitable for radio-frequency applications, with improved radio-frequency properties. For this purpose, the process comprises the steps of:

- depositing a structured glass layer (9, 91, 92, 93, 13) having at least one opening (8) over a contact-connection region (71 - 74) by evaporation coating on the substrate (1), and
- applying at least one conductor structure (100, 111, 112, 113) to the glass layer (9, 91 - 93), which has electrical contact with the contact-connection region (71 - 74).



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